

Substitute for form 1449/PTO (Revised 07/2007) INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
				Application Number	10/572,764
				Filing Date	May 16, 2007
				First Named Inventor	Joseph M. DeSimone
				Art Unit	1792
				Examiner Name	Lightfoot, Elena Tsoty
Sheet	1	of	6	Attorney Docket Number	035052/338792

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Examiner Initials*	Cite No.	Document Number Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages of Relevant Figures Appear
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
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